## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re the Application of

Yukie NAKANO et al.

Application No.: 09/865,575

Group Art Unit: 2831

Examiner:

Eric W. Thomas

Filed: May 29, 2001

Docket No.:

109639%

For:

MULTILAYER CERAMIC CAPACITOR AND PRODUCTION METHOD THERE

## LARGE ENTITY REQUEST FOR CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114

Director of the U.S. Patent and Trademark Office Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant(s) hereby request(s) continued examination and entry and consideration of the December 2, 2002 Amendment After Final Rejection submission. The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. <u>138514</u> in the amount of  $\boxtimes$  \$750.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Director is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,

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Date: January 29, 2003

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE AUTHORIZATION

Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461 01/30/2003 WABDELR1 00000037 0986557